

Reply Under 37 CFR 1.116 – Expedited Procedure – Technology Center 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Yasuhiro WATANABE, et al. : Confirmation Number: 4618
Application No.: 10/575,680 : Group Art Unit: 2828
Filed: April 13, 2006 : Examiner: ZANG, Yuanda
For: TWO-BEAM SEMICONDUCTOR LASER APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendment and remarks are submitted in response to the Office Action mailed July 17, 2008.